

Docket No.: 43890-560

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Kunio KISHIMOTO, et al.

Serial No.:

Group Art Unit:

Filed: February 08, 2002

Examiner:

For: METHOD AND SYSTEM OF DRYING MATERIALS AND METHOD OF
MANUFACTURING CIRCUIT BOARDS USING THE SAME

CLAIM OF PRIORITY

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

In accordance with the provisions of 35 U.S.C. 120, Applicants hereby claim the priority of U. S. Patent Application No. PCT/JP01/04819, filed June 7, 2001, of which this application is a Continuation-In-Part, which claims the benefit of the priority under 35 U.S.C. 199 of:

Japanese Patent Application No. 2000-171539, filed June 8, 2000

The certified copy was filed July 27, 2001 in support of the claim of priority.
Acknowledgement is respectfully requested.

Respectfully submitted,

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